Large chip improvements to deep-ultraviolet output

Sensor Electronic Technology characterizes large-area 273nm and 247nm LEDs.

Sensor Electronic Technology (SET) of Columbia, SC, USA has reported details of their achievement of continuous-wave (CW) 6mW and 30mW light output power from single-chip LEDs operating at wavelengths of 247nm and 273nm, respectively [Max Shatalov et al, Appl. Phys. Express, vol3, p062101, 2010]. In addition to the SET researchers, two scientists from the US Army Research Lab also contributed to the work.

Potential applications for such devices include defense/security, bio-analysis, medical, chemical sensors, and curing of materials.

The deep-ultraviolet (DUV) wavelengths (<300nm) are particularly being developed for non-thermal disinfection/sterilization of water and other materials, and decontamination of surfaces. Short-wavelength light (∼260nm) disrupts DNA structures, killing microorganisms.

Recent work at SET to increase light output power (L) has focused on creating larger-area chips. The company uses MOCVD and SET’s own migration-enhanced MOCVD (MEMOCVD) processes to create the diode layers on sapphire substrates. The final chips were 0.5mm² or 1mm² in area.

The metallization was performed on 100nm mesas (Figure 1) formed through reactive ion etch (RIE) processing. The aim was to create uniform current spreading. The large chip sizes help in heat dissipation from the junction. The n-contact consisted of chromium/titanium/gold (Cr/Ti/Au) layers that were annealed in nitrogen above 850°C. Linear transfer length model measurements give a contact resistance of 5×10⁻⁵Ω-cm² on the Al₀.₈Ga₀.₂N layers used in the n-contacts of the 273nm devices. This increased to 10⁻⁴Ω-cm² for the Al₀.₈Ga₀.₂N layers of the 247nm LED. The p-contact consisted of nickel/gold (Ni/Au) annealed in air at 500°C.

The devices were separated using laser scribing and packaged into TO-3 cans with a customized copper heatsink. Use of the larger-junction chips resulted in a significant reduction of forward voltages (6.5V at 700mA, with maximum CW light output power of nearly 30mW with no special thermal management measures, short pulsing of 1ms gave 65mW at 1.4A), giving a differential resistance (R𝑑) of less than 1Ω. Measurements of various chip sizes at a current of 20mA give a differential resistance that is inversely proportional to the junction area between 0.035mm² and 1mm². The researchers comment that this indicated that the dominant contributions to this resistance come from the p-n junction and the p-contact.

The larger devices were limited in further reduction of differential resistance to 10Ω at 20mA due to problems with current spreading in the n-AlGaN layer.

The emission spectrum of the 273nm device at 20mA (Figure 2) has a full-width half-maximum (FWHM) of 10nm, with the secondary peak at ~420nm suppressed by more than three orders of magnitude. This suggests good confinement of injected carriers into the multi-quantum-well active region, rather than allowing overshoots into regions where longer-wavelength recombination takes place.

The external quantum efficiency (EQE) performance at higher currents is also much improved for the 273nm device (Figure 2). The smaller devices peak at about 1.3% EQE but fall off rapidly. For the larger
device the EQE also peaks at about 1.3% (wall-plug efficiency/WPE 1%) at a higher current ~100mA, but falls off much more slowly. The difference in performance is blamed on joule heating in the smaller device at high currents.

The reduced power at shorter wavelengths is largely attributed to the poorer material quality of the high-Al-content AlGaN layers needed to create higher-energy photons. The operating voltage also increases due to the higher resistance of the contacts and AlGaN layers. Due to higher concentrations of non-radiative recombination centers, the current density needed for the peak EQE in the 247nm device was higher. To enable this higher current density, the researchers used a smaller 0.5mm² area chip.

Operation at a CW 200mA forward current (10V) resulted in 5mW light output, corresponding to an EQE of 0.5% and WPE of 0.25%. The big reduction in WPE is blamed on the joule losses associated with the higher voltage drops across the contact and barrier layers in these devices. The researchers believe that new doping approaches and contact fabrication processes need to be investigated with a view to reducing these losses in efficiency.

In terms of the spectral output, the 247nm devices were similar in performance to the 273nm LEDs, with an FWHM of 10nm and a suppression factor of 500 for the secondary peak.

The reliability of a 0.5mm² 273nm device was also evaluated in quasi-CW operation (400ms pulses with 10% duty cycle) at 400mA. Accelerated stressing at around 100°C was achieved by packaging the device without a heat-sink. The initial output of 26mW increased to 31mW after 250 hours, and then returned to 26mW after 1500 hours. The initial increase is attributed to an annealing effect of the temperature on the p-type layers, increasing hole injection into the active layers. Using an extrapolation of the fall-off, the researchers give a time to 50% power of almost 5000 hours.

The researchers have carried out research into the degradation mechanisms for these devices [Craig G. Moe et al., Appl. Phys. Lett., vol96, p213512, 2010], finding that the electrical properties of the p-type layers change over time, reducing carrier injection and hence output power.

Figure 2. (a) CW I–V and R–I characteristics of 1mm² DUV LED with 273nm emission. Inset: LED emission spectrum at 20mA CW. (b) L–I and EQE–I characteristics of 0.035mm² (open symbols) and 1mm² (closed symbols) DUV LEDs.

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